



Research Associate/Postdoctoral Associate Position in the Area of Advanced Manufacturing

National Institute of Advanced Studies, Bengaluru

The National Institute of Advanced Studies (NIAS), a visionary initiative of J. R. D. Tata, has a mandate to create leaders of substance and credibility in a variety of domains in India, and to carry out in-depth, policy relevant research from a multi-disciplinary perspective, drawing on a wide spectrum of disciplines in the humanities, social sciences and natural sciences. NIAS provides a congenial atmosphere and institutional support for faculty and scholars to pursue their research and career goals, and expects them to produce significant outcomes in line with the institution's mandate. Please visit our website (www.nias.res.in) for a comprehensive perspective.

NIAS invites applications for the post of Research Associate/Postdoctoral Associate, to work in the area of Advanced Manufacturing with preferred capacity in Digital Technologies.

Educational qualification and experience

Applicants should hold a Master's degree in applied science or engineering. Knowledge in advanced manufacturing, especially digital manufacturing will be essential. Applicants should be well versed with the use of computer, website, facebook, etc.

Salary will be commensurate with qualification and experience, and comparable to other premier institutions in the country.

Selected candidate would have the opportunity to work directly with Prof. Baldev Raj and other eminent experts in the field of Advanced Manufacturing.

Note: Recently retired scientists and technologists from government organizations, having the prescribed qualifications and below the age of 62 with interest in the above field may also apply.

Application: Applicants should submit their curriculum vitae electronically including the names and addresses of three referees, samples of published work, if any and a brief statement of interest explaining why they are interested in joining this programme at NIAS in one single PDF file. The applications should be addressed to:

The Head, Administration, National Institute of Advanced Studies, Bengaluru 560 012, e-mail: admin@nias.iisc.ernet.in.

The deadline for applications is **20 May 2017**. Short-listed candidates will be invited to NIAS for a presentation and an interview.



भा.कृ.अ.प.—सरसों अनुसंधान निदेशालय
ICAR-Directorate of Rapeseed Mustard Research
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F. No. 6-117/E/2017

Dated: 25 April 2017

Attend walk-in-interview at **11.00 am** on **20 May 2017** at DRMR, Sewar, Bharatpur (Raj.) 321 303 along with original degree certificates, with one set of photocopies, two passport size photographs for the following positions. These positions are purely temporary/ad-hoc and co-terminus, and number of position can be increased/decreased.

Junior Research Fellow: One.

Project: Development of low glucosionlate phytic acid mutants of low erucic acid genotypes in Indian mustard under BRNS project.

Essential qualification: M.Sc. in Biochemistry/Agriculture Biochemistry/Genetics and Plant Breeding with 4 years/5 years of Bachelor's degree. Candidates having postgraduate degree in Basic Sciences in above subjects with 3 years Bachelor's degree and 2 years Master's degree should have NET qualification. Preference will be given to Biochemistry candidates.

Desirable: Knowledge of computer application, handling of instruments in the laboratory, e.g. spectrophotometer, GLC, HPLC, NMR, etc. and experience in conduct of lab and field experiments.

Note

- (1) Age: 30 years for JRF. Relaxation of 5 years for women candidates and relaxation to reserved category candidates as per GoI/ICAR rules.
- (2) Emoluments for JRF is Rs 25,000 + HRA (Fixed) without DA for all (as per ICAR circular no. Edn. 6/27/2014/HRD dated 13-07-2015). No TA/DA shall be given for attending the interview.
- (3) The Director's decision will be final and binding in all respects.

Asstt. Admn. Officer